

Amendments to the Claims:

This listing of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims:

1. (Currently Amended) A method of manufacturing an oxide superconductive wire, comprising:

the step of positioning a metal tape [(6)] in a position at a distance (L) of at most 100 mm from a target [(7)] for generating an oxide; and

the only one step of forming an oxide superconductive layer [(12)] on said metal tape [(6)] with one set of the target and laser light using a vapor deposition method while transferring said metal tape [(6)] at a transfer speed of at least 5 m/h with keeping the distance [(L)] between said metal tape [(6)] and said target [(7)] of at most 100 mm.

2. (Original) The method of manufacturing an oxide superconductive wire according to claim 1, wherein

said vapor deposition method is a pulsed laser deposition (PLD) method.

3. (Currently Amended) The method of manufacturing an oxide superconductive wire according to claim 1, wherein

said oxide superconductive layer [(12)] is a rare-earth-barium-copper-based superconductive oxide (RE123; RE = rare-earth element, Y).